OAK RIDGE NATIONAL LABORATORY

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Aerosol Beam-Focus Laser-Induced Plasma Spectrometer

Disclosure Number

199900706

Technology Summary

Aerosol beam-focusing and laser-induced plasma spectroscopy are coupled in an analytical instrument characterized by increased sensitivity, greatly reduced size (footprint) and energy consumption, making it ideal for in-situ field use.

Inventor

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Licensing Contact

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Note: The technology described above is an early stage opportunity. Licensing rights to this intellectual property may be limited or unavailable. Patent applications directed towards this invention may not have been filed with any patent office.